

<b>Notice of References Cited</b>	Application/Control No. 10/098,550	Applicant(s)/Patent Under Reexamination CHEN, LIN-HUNG	
	Examiner Kim T. Huynh	Art Unit 2112	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,157,970 A	12-2000	Gafken et al.	710/27
	B	US-2003/0037198 A1	02-2003	Hunsaker, Mikal C.	710/313
	C	US-6,327,636 B1	12-2001	Guthrie et al.	710/119
	D	US-2002/0144037 A1	10-2002	Bennett et al.	710/105
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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